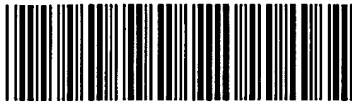


**Search Notes**

Application/Control No.

10/707,356

Examiner

Paul D. Kim

Applicant(s)/Patent under  
Reexamination

LEE ET AL.

Art Unit

3729

**SEARCHED**

Class	Subclass	Date	Examiner
29	592.1 832	5/26/2006	PK
250	208.1 553		
257	40		
315	169.3		
	169.4 504		
345	205 207		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Consulted by Thuy Tran (315) No Search	2/14/2006	PK
Eddie Lee (257) No Search	3/21/2006	PK
Marie Yamnitzky (428) No Search	2/13/2006	PK
Review the US Application 10/707,355 (Pending)	5/26/2006	PK
Text Search EAST/NPL (IEEE)	5/26/2006	PK